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INFORMATION DISCLOSURE CITATION

In re application of: Dan Lillie et al.

Serial No: 10/073,503

Group No.: 1746

Filed: February 11, 2002

Examiner: Unknown

For:

ETCHING SOLUTION FOR FORMING AN EMBEDDED RESISTOR

Assistant Commissioner for Patents

Washington, DC 20231

U.S. Patent Documents

Examiner	Document			•
Initials	Number	Name	Date	Class
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Pr	2,687,345	Murray	August 24, 1954	41/42
M	3,102,808	Weisberg et al.	September 3, 1963	75/97
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Examiner: Roberts . P. Culbert Acht of Callet

Date Considered:

2/12/2004

**Examiner:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.